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Docket No.: TSL-124

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Micha Gutman, et al

Application No.: 10/659,042

Group No.:2812

Filing Date: September 9, 2003

Examiner: Richard A. Booth

For: "METHOD OF DECREASING CHARGING EFFECTS IN
OXIDE-NITRIDE-OXIDE (ONO) MEMORY ARRAYS"

Date: October 22, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY

1. More than twelve months have passed since the filing of this application on September 9, 2003. No communication has been received from the Patent and Trademark Office indicating action on this application.
2. Kindly advise the undersigned of the present status of this application.



SIGNATURE OF PRACTITIONER

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